FORM PTO-1449 (REV.7-80)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO. 501085.02

APPLICATION NO. Not Yet Assigned

APPLICANT(S)

Dirk J. Sundt et al.

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Sheet <u>1</u> of <u>1</u> ATTY. DOCKET NO. APPLICATION NO. U.S. DEPARTMENT OF COMMERCE (REV.7-80) PATENT AND TRADEMARK OFFICE 10/620,782 501085.02 APPLICANT(S) INFORMATION DISCLOSURE STATEMENT Dirk J. Sundt et al. (Use several sheets if necessary) FILING DATE GROUP ART UNIT July 15, 2003 Not Yet Assigned **U.S. PATENT DOCUMENTS** *EXAMINER CLASS DOCUMENT NUMBER DATE SUBCLASS NAME FILING DATE INITIAL IF APPROPRIATE 6,177,331 B1 01/23/01 Koga 438 424 6,548,371 B2 04/15/03 Fujimaki 438 424 AB AC ΑD SEP 1 5 2003 ΑE AF AG AH ΑI FOREIGN PATENT DOCUMENTS DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS TRANSLATION YES AK AL AM ΑN ΑO OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.) Cheung, N., Lecture notes (handout) EE 143, Lecture 15, University of California Berkely, 2000. ΑP Clark, S., "Chemical Etching of Silicon Nitride (Si3N4) with Hot Phosphoric Acid (H3PO4)", Bold Technologies Technical Paper, 2000, pp. 1-6. EXAMINER s Mage DATE CONSIDERED 9/20/04

conformance and not considered. Include copy of this form with next communication to applicant(s).

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